

# **Notice of References Cited**

Application/Control No.

10/590,847

Applicant(s)/Patent Under  
Reexamination  
KITAO ET AL.

Examiner

Megan Arnberg

Art Unit

1796

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## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,849,532 A	07-1989	Boehme et al.	549/525
*	B	US-5,446,176 A	08-1995	Kuwana et al.	549/546
*	C	US-6,201,070 B1	03-2001	Kumabe et al.	525/327.3
*	D	US-2003/0059618 A1	03-2003	Takai, Hideyuke	428/413
*	E	US-2004/0242839 A1	12-2004	Takai, Hideyuki	528/408
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

## **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	R					
	O					
	R					
	S					
	T					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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